

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05918-083002	Application No. 09/745,786
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))		Applicant Thomas G. Lacey, et al.	
		Filing Date December 21, 2000	Group Art Unit 3626

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
AS/212001	SA	5,385,706	Jan. 31, 1995	Thomas, Dennis A.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						SEP 25 2001
	AH						
	AI						103600 MAIL ROOM
	AJ						
	AK						

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**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No
	AL						
	AM						
	AN						
	AO						
	AP						

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

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SEP 27 2001

Examiner Signature <i>M. Lacey</i>	Date Considered 20/Jun/03 TC 1700
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(Modified)

U.S. Department of Commerce  
Patent and Trademark Office

Attorney's Docket No.  
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Applicant  
Thomas G. Lacey, et al.

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December 21, 2000

Group Art Unit

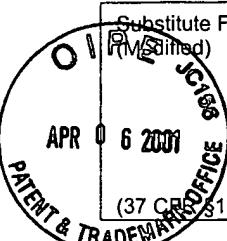
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**U.S. Patent Documents**

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
MC	AA	3,312,583	04/04/1967	Rochlis	161	62	6/2001
MC	AB	3,507,010	04/21/1970	Doleman et al.	18	21	
MC	AC	3,557,407	01/26/1971	Lemelson	18	10	
MC	AD	3,590,109	06/29/1971	Doleman et al.	264	167	
MC	AE	3,752,619	08/14/1973	Menzin et al.	425	134	
MC	AF	3,758,657	09/11/1973	Menzin et al.	264	166	
MC	AG	3,762,000	10/02/1973	Menzin et al.	24	204	
MC	AH	4,162,757	07/31/1979	Lemelson	228	1 R	
MC	AI	4,725,221	02/16/1988	Blanz	425	575	
MC	AJ	4,794,028	12/27/1983	Fischer	428	100	
MC	AK	4,984,339	01/15/1991	Provost et al.	24	452	
MC	AL	5,058,247	10/22/1991	Thomas et al.	24	448	
MC	AM	5,077,870	01/07/1992	Melbye et al.	24	452	
MC	AN	5,116,563	05/26/1992	Thomas et al.	264	167	
MC	AO	5,131,119	07/21/1992	Murasaki et al.	24	452	
MC	AP	5,162,074	11/10/1992	Hills	156	644	
MC	AQ	5,176,670	01/05/1993	Roessler et al.	604	391	
MC	AR	5,235,731	08/17/1993	Anzai et al.	24	576	
MC	AS	5,242,646	09/07/1993	Torigoe et al.	264	219	
MC	AT	5,312,456	05/17/1994	Reed et al.	411	456	
MC	AU	5,315,740	05/31/1994	Provost	24	452	
MC	AV	5,326,612	07/05/1994	Goulait	428	100	
MC	AW	5,339,499	08/23/1994	Kennedy et al.	24	452	
MC	AX	5,348,616	09/20/1994	Hartman et al.	156	643	
MC	AY	5,441,687	08/15/1995	Murasaki et al.	264	167	
MC	AZ	5,505,747	04/09/1996	Chelsey et al.	51	297	
MC	AAA	5,538,674	07/23/1996	Nisper et al.	264	1.31	

Examiner Signature <i>MC</i>	Date Considered 20/Jan/03
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Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR 1.98(b))		Applicant Thomas G. Lacey, et al.		RECEIVED APR 6 2001 C
		Filing Date December 21, 2000	Group Art Unit	TO

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
MC	ABB	5,604,963	02/25/1997	Akeno	24	452	
MC	ACC	5,679,302	10/21/1997	Miller et al.	264	167	
MC	ADD	5,692,271	12/02/1997	Provost et al.	24	452	
MC	AEE	5,781,969	07/21/1998	Akeno et al.	24	452	10/31/1996
MC	AFF	5,900,350	05/04/1999	Provost et al.	430	325	06/06/1996
MC	AGG	5,945,131	08/31/1999	Harvey et al.	425	141	04/16/1997
MC	AHH	5,971,738	10/26/1999	Jens et al.	425	194	01/21/1997
MC	AII	6,039,556	03/21/2000	Jens et al.	425	363	09/10/1997
	AJJ						

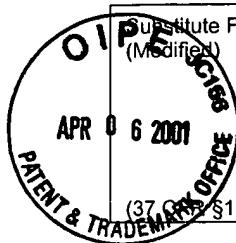
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Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes      No
MC	AKK	EP 0 464 754 A1	07/01/1991	EPO			
MC	ALL	EP 0 698 351 A2	08/24/1995	EPO			
MC	AMM	EP 0 714 614 A1	11/27/1995	EPO			
MC	ANN	GB 2 296 423	03/26/1997	UK			
MC	AOO	WO 94/23610	10/27/1994	WIPO			
MC	APP	WO 96/19960	07/04/1996	WIPO			
MC	AQQ	WO 97/46130	12/11/1997	WIPO			
MC	ARR	WO 98/20767	05/22/1998	WIPO			

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
MC	ASS	"What is the Photo Chemical Machining Process and What Can It Do For You?", <i>Photo Chemical Machining Institute</i> -San Clemente, CA
MC	ATT	Bennett, R.J., "Photo-Chemical Machining Fundamentals-With Three Unique Applications", <i>Technical Paper</i> , Creative Manufacturing Engineering Programs, Society of Manufact. Engineers, Dearborn, Michigan, 1976

Examiner Signature <i>M. E. L.</i>	Date Considered <i>20 Jan 03</i>
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		Filing Date December 21, 2000	Group Art Unit	

<b>Other Documents (include Author, Title, Date, and Place of Publication)</b>		
Examiner Initial	Desig. ID	Document
MC	AUU✓	Freeman, H. "Manufacturing Metal Parts by the Photo-Chemical Machining Process", Conference Proceedings, Nontraditional Machining, Cincinnati, Ohio, 2-3 Dec. 1985, Carl Wegner, Chairman
MC	AVV✓	Han et al, Micromechanical Velcro, J. of Micromechanical Systems, vol. 1 pp. 37-43, 1992
	AWW	

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